

<b>Notice of References Cited</b>	Application/Control No. 10/602,557	Applicant(s)/Patent Under Reexamination MAKOWSKI ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"LabView Advanced Application Development, Part 2: Coding Techniques", February 2002 (73 pages). Online retrieved at <www.physics.utah.edu/LabVIEW>.
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